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|---|-----------------------------------|---------------------------|---------------------------------|--|
| AMENDMENT TRANSMITTAL LETTER | | | Docket No. 09852/0205523-US0 | |
| Application No. 10/599,440-Conf. #8901 | Filing Date September 28, 2006 | Examiner A. M. Crowell | Art Unit 1792 | |

Applicant(s): Hideki Fujiwara et al.

Invention: SILICON ELECTRODE PLATE FOR PLASMA ETCHING WITH SUPERIOR DURABILITY

TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.
The fee has been calculated and is transmitted as shown below.

| CLAIMS AS AMENDED | | | | | | |
|---|---|---|-----------------------------------|----------|------|--|
| | Claims Remaining After Amendment | Highest Number Previously Paid | Number Extra Claims Present | Rate | | |
| Total Claims | 2 | - 20 = | 0 | x 52.00 | 0.00 | |
| Independent Claims | 1 | - 3 = | 0 | x 220.00 | 0.00 | |
| Multiple Dependent Claims (check if applicable) <input type="checkbox"/> | | | | | | |
| Other fee (please specify): | | | | | | |
| TOTAL ADDITIONAL FEE FOR THIS AMENDMENT: | | | | | 0.00 | |

☒ Large Entity
 ☐ Small Entity

☒ No additional fee is required for this amendment.

☐ Please charge Deposit Account No. _____ in the amount of \$ _____.

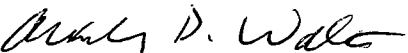
☐ A check in the amount of \$ _____ to cover the filing fee is enclosed.

☐ Payment by credit card. Form PTO-2038 is attached.

☒ The Director is hereby authorized to charge and credit Deposit Account No. 04-0100 as described below.

☒ Credit any overpayment.

☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.



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